

L Number	Hits	Search Text	DB	Time stamp
6	29	(351/45,51,165.ccls. and (dielectric or interference or asymmetr\$8 or antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or conduct\$8)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 13:00
7	218	(351/41,44,47,49,159,163,166,177.ccls. and (dielectric or interference or asymmetr\$8 or antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or conduct\$8)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 15:27
8	5	((359/\$.ccls. and ((interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4))) and (metal\$8 or conductive or conducting)) and lens adj wafer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 13:05
9	408	((lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and ((metal\$8 or conductive or conducting) adj layer) and (laminat\$4 or cement\$4)) and ((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer)) and ((multi or multiple or plural\$3) adj layer\$3 or multilayer\$3)) and (mark\$4 or logo or decorat\$4 or relief or pattern)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 13:08
11	107	359/\$.ccls. and ((lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and ((metal\$8 or conductive or conducting) adj layer) and (laminat\$4 or cement\$4)) and ((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 14:29
12	25	351/\$.ccls. and (lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) near\$3 (filter or coat\$4 or mirror or layer\$4 or multi or multilayer\$4)) and ((metal\$8 or conductive or conducting) adj layer)) and (mark\$4 or logo or decorat\$4 or relief or pattern)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 14:35
13	43	359/\$.ccls. and ((lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and (laminat\$4 or cement\$4 or lens adj wafer)) and (((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer)) with ((metal\$8 or conductive or conducting) adj layer))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 14:38
14	1	351/\$.ccls. and ((lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and (laminat\$4 or cement\$4 or lens adj wafer)) and (((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer)) with ((metal\$8 or conductive or conducting) adj layer))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 14:36
15	301	lens and ((band or passband or interference or dielectric or (asymmetr\$8 or anti) adj reflect\$4 or antireflect\$4) adj (filter or coating or mirror or layer\$4 or multi or multilayer\$4)) and (laminat\$4 or cement\$4 or lens adj wafer) and ((dielectric or non adj conduct\$4 or nonconduct\$4 or oxide or "SiO.sub.2" or transparent or non adj absor\$5 or nonabsor\$5) adj layer) with ((metal\$8 or conductive or conducting) adj layer)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 14:47
16	352	351/163.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 15:31

20	59	359/585.ccls. and lens	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 16:28
21	327	359/360.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 16:28
22	68	359/360.ccls. and lens	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 16:28

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1	37	((351/41,44,47,49,159,163,166,177.ccls. and (dielectric or interference or asymmetr\$8 or antireflect\$4 or anti adj refelect\$4)) and (metal\$8 or conduct\$8)) and plasma	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 11:53
2	15	351/\$.ccls. and niobium	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 11:56
3	57	359/585.ccls. and niobium	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/07 12:34